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SC12752TP

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15 Number of Pages (including this page)

Date:

October 6, 2005

To:

Laura M. Schillinger - 2813

Location:

United States Patent and Trademark Office

Fax No.:

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From:

Michael J. Balconi-Lamica-34,291

Subject:

10/687,271- Olubunmi O. Adetutu et al.

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ALL ITEMS MARKED WITH AN "X" ARE INCLUDED:

		<u> </u>
1.	х	1 page Facsimile Cover Sheet
2.	х	3 page Information Disclosure Statement
3.	Х	2 page Form PTO/SB/08 with References BG-BK

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Applicat Applicat Date Fil	tion No.:	Olubunmi O. Adetutu et al. 10/687,271 October 16, 2003	Group Art Unit: Examiner: Docket No.:	2813 Laura M. Schillinger SC12752TP
Title:		MULTI-LAYER DIELECTRIC CON	TAINING DIFFUSION BA	ARRIER MATERIAL
				ansmission under 37 CFR 1.8
			Ceruncals of 112	Sisilission unua 37 CPA 1.0
			I hereby certify that this Trademark Office.	correspondence is being facsimile transmitted to the Patent and
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		INFORMATION DISCL	OSURE STATEMENT	(IDS)
Commis	sioner for I	Patents		
	x 1450			
Alexan	dria, VA	22313-1450		
SIR:	In accor	company with 27 CER 81.56 and in comp	oliones with 37 CED &	§1.97 and 1.98, the references listed on
	Form PT			d herewith for consideration by the United
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	a.🔀	A legible copy of (i) each foreign patent; (iii) all other information or that portion wh		at portion which caused it to be listed; and
	b. 🔲	Any patents, publications or other infor	mation which are listed	i on PTO/SB/08 which are not enclosed
		herewith were previously cited by or subbeen relied upon for an earlier filing date	omitted to the PTO in or under 35 U.S.C. §120:	ne of the following applications which has
		U.S. Serial Number	<u>U.S. F</u>	iling Date
H.		EXPLANATION OF THE RELEVANCE (
	a. 🔀	except as may be indicated below in (b) are in the English language (concise explanation)		patents, publications or other information
	b. 🗵	A concise explanation of the relevance of	all patents, publications	or other information listed that is not in the
	c. 🔲	English language is as follows: An English		
	v. Ц	The following additional information is pro	vided for the Examiners	consideration:
III. 🗀		REFERENCE TO RELATED APPLICATIO		
	The Exam	niner is advised that the following co-pend int application. By bringing this (these) a	ding application(s) contain applications to the Exam	in(s) subject matter that may be related to iner's attention, Applicant(s) does(do) not

Art Unit

Filing Date

waive the confidentiality provisions of 35 U.S.C. §122.

Serial No.

SC12752TP

FEES

IV. 🔯	THIS ID	S IS BEING FILED UNDER 37 C.F.R. §1.97(b): (check one box)
	a. []	within three months of the filing date of a national application other than a continued prosecution application under § 1.53(d) (37 C.F.R. §1.97(b)(1)). No fee or statement is required.
	b. 🔲	within three months of the date of entry of the national stage as set forth in § 1.491 in an international application (37 C.F.R. §1.97(b)(2)). No fee or statement is required.
	c.⊠	before the mailing date of a first Office Action on the merits (37 C.F.R. §1.97(b)(3)). No fee or statement is required.
	d. □	before the mailing date of a first Office Action after the filing of a request for continued examination under § 1.114 (37 C.F.R. § 1.97(b)(4)). No fee or statement is required.
V. 🗆	before th	S IS BEING FILED UNDER 37 C.F.R. §1.97(c): (check one box) the mailing date of any of a Final Office Action under 37 C.F.R. §1.113, a Notice of Allowance under 37 C.F.R. or an action that otherwise closes prosecution in the application (See 37 C.F.R. §1.97(c)). No statement; therefore, charge Deposit Account 503079 the fee set forth in 37 C.F.R. §1.17(p). See the statement below. No fee is required.
VI. 🗖		S IS BEING FILED UNDER 37 C.F.R. §1.97(d): fore payment of the issue fee and is accompanied by the following: a statement under 37 C.F.A. §1.97(e) as provided below; and charge Deposit Account 503079 the petition fee set forth in §1.17(p).
VII. 🔲	The und	IENT UNDER 37 C.F.R. §1.97(e) (check only one box, if applicable) ersigned hereby states that
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		counterpart foreign application, and to knowledge of the person signing the statement after making reasonable inquiry, no item of information contained in the IDS was known to any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of this statement, or
	c. 🗀	some of the items of information contained in the IDS were cited in a communication from a foreign Patent Office. As to this information, the undersigned states that each item of information contained in the IDS was cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this IDS. As to the remaining information, the undersigned hereby states that no item of this remaining information contained in the IDS was cited in a communication from a foreign Patent Office in a counterpart foreign application or, to the knowledge of the person signing the statement after making reasonable inquiry, no item of information contained in the IDS was known to any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of this statement.
VIII.	PAYMEN	TOF FEES A check in the amount of is enclosed for the above-identified fee(s).
		Please charge Deposit Account No. 503079, Freescale Semiconductor, Inc. in the amount of \$180.00 for the above-indicated fee(s).
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		Two Copies of this paper are attached for Deposit Account charges and debits.
	The above	re references are being cited only in the interests of candor and without any admission that they constitute

statutory prior art or contain matter which anticipates the invention or which would render the same obvious, either singly or in a

combination, to a person of ordinary skill in the art.

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Con Jamica

If the Examiner has any questions concerning this IDS, he/she is requested to contact the undersigned. If it is determined that this IDS has been filled under the wrong rule, the PTO is requested to consider this IDS under the proper rule (with a petition if necessary) and charge the appropriate fee to Deposit Account No. 503079, Freescale Semiconductor, Inc.

Respectfully submitted, Olubunmi O. Adetutu et al.

Michael J. Balconi-Lamica Attorney for Applicant(s)

Reg. No. 34,291 Tel. 512-996-3839

FREESCALE SEMICONDUCTOR, INC. Customer Number 23125

Enclosures:

PTO/SB/08

References BG-BK

Other:

next communication to applicant.

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Substitute for form 1449A/PTO			Complete If Known		
			Application Number	10/687,271	
INFORMATION DISCLOS			Filing Date	October 16, 2003	
STATEMENT BY APPLICA	ANT		First Named Inventor	Olubunmi O. Adetutu et al.	
			Group Art Unit	2013	
(use as many sheets as necessary)			Examiner Name	Laura M. Schillinger	
Sheet 1	of	1	Attorney Docket Number	SC12752TP	

Examiner	Cite No.	11001.45		U. S. PATENT DOCUMENTS		
Initials"	ı	U.S. Patent D Number	Jocument Kind Code? (If known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	BA	5,308,601		Hampden-Smith et al.	05/03/1994	
	BB	5,972,804		Tobin et al.	10/26/1999	
	BC BC	6,350,643	Bl	Hintermaier et al.	02/26/2002	
	BD	6,486,080	B2	Chooi et al.	11/26/2002	
	BE	6,500,735	B2	Ususa	12/31/2002	
	BF	6,544,900	B2	Raaijmakers et al.	04/08/2003	
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Examiner	Cite No.		Foreign Patent	Document	Name of Patentee or	Date of Publication	Pages, Columns, Lines,	14
initials*	<u> </u>	Offices	Number 4	Kind Code ² (il known)	Applicant of Cited Document	of Cited Document MM-DD-YYYY	Where Relevant Passages or Relevant Figures Appear	
	BG	JP	63-23635		Masanobu	10/01/1988		
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Examiner	Date	
Signature	Considered	
EXAMINER: Initial II reference considered, whether or not citation is in conformance v	mith MPEP 609. Oraw line through citation, if not in	conformance and not considered. Include copy of this farm with

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X Please type a plus sign (+) inside this box. Substitute for form 1449A/PTO Complete if Known Application Number 10/887,271 INFORMATION DISCLOSURE October 16, 2003 Filing Date STATEMENT BY APPLICANT First Named Inventor Olubunmi O. Adetutu et el. Group Art Unit 2813 Laura M. Schillinger (use as many sheets as necessary) Examiner Name Sheet lof Attorney Docket Number SC12752TP

Staminer	Cite No.	OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS	72
nitials"	Cité No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	'
	BH	Bycong-Ok Cho et al., "Tuning the Electrical Properties of Zirconium Oxide Thin Films," Applied Physics Letters, February 11, 2002, Vol. 80, No. 6, pp. 1052-1054.	
	ВІ	A. L. P. Rotondaro, et al., "Advanced CMOS Transistors with a Novel HfSiON Gate Dielectric," 2002 Symposium on VLSI Technology Digest of Technical Papers, Section 15.2.	
	BJ	Yuji Saito, et al., "Advantage of Radical Oxidation for Improving Reliability of Ultra-Thin Gate Oxide," 2002 Symposium on VLSI Technology Digest of Technical Papers.	
	BK	M. Togo, et al., "Low-Leakage and Highly-Reliable 1.5 nm SiON Gate-Dielectric Using Radical Oxynitridation for Sub-0.1 μm CMOS," 2000 Symposium on VLSI Technology Digest of Technical Papers.	
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Examiner		Date	
Signature		Considered	
EXAMINER: Initial if	reference considered, whether or not citation is in conformance with MPEP 609. Draw line th	rough cilation, if not	in conformance and not considered. Include copy of this form with
next communication t	o applicant.	-	

1 Unique citation designation number. 2 Applicant is to place a check mark here if English Language Translation is attached.